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Docket Number: 081468-0309201

PATENT APPLICATION



Client Reference: P-0201.020-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of

YIM BUN PATRICK KWAN

Group Art Unit: 2877

Application No.: 10/825,215

Examiner: UNKNOWN

Filed: April 16, 2004

Confirmation No.: 7263

For: LITHOGRAPHIC APPARATUS, DEVICE MANUFACTURING METHOD AND DEVICE  
MANUFACTURED THEREBY

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Copies of cited U.S. patents and patent application publications are not included. Copies of foreign patent documents and non-patent literature are included. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicant respectfully requests the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicant with the next Office communication to indicate that the references have been considered, per MPEP § 609.

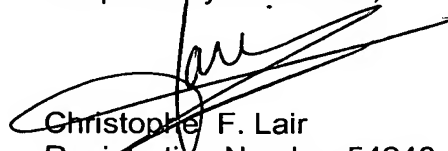
This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

The references were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.

Application No. 10/825,215  
Atty. Docket No. 081468-0309201

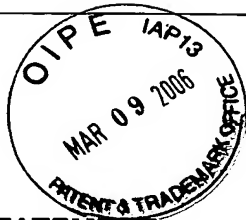
The patents, publications, or other information listed on the attached PTO-1449 are in the English language and therefore, do not require a statement of relevancy.

Respectfully Submitted,



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Date: March 9, 2006  
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Atty. Dkt. No.	M#	Client Ref.
	0309201	P-0201.020-US

**INFORMATION DISCLOSURE STATEMENT  
BY APPLICANT**

Applicant: Yim Bun Patrick KWAN

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Date: March 9, 2006

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of

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Examiner: UNKNOWN

Group Art Unit: UNKNOWN

**U.S. PATENT DOCUMENTS**

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR	4,540,277	A	09/10/1985	Mayer et al.		
	BR	5,978,069	A	11/02/1999	Kato		
	CR						
	DR						
	ER						
	FR						
	GR						
	HR						
	IR						
	JR						

**FOREIGN PATENT DOCUMENTS**

		Document Number	Date MM/YYYY	Country	Inventor Name		Abstract		Readily Available	
							Enclosed	No	Enclose	No
	KR	0 951 054	A1	10/20/1999	European Patent Office	NISHI et al.			X	
	LR	0 652 487	A1	05/10/1995	European Patent Office	SAITOH et al.			X	
	MR									
	NR									
	OR									
	PR									
	QR									
	RR									
	SR									
	TR									

**OTHER (Including in this order: Author, Title, Periodical Name, Date, Pertinent Pages, etc.)**

	UR	Jim Dey, "Precision wafer stepper utilizing a two-dimensional optical encoder", SPIE Semiconductor Microlithography VI, Vol. 275 pp. 29-34 (1981), XP009039090			X
	VR	European Search Report issued on EP Application No. 01307129.5 dated February 8, 2006			X
	WR				
	XR				
	YR				
	ZR				

Examiner

Date Considered:

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.